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PEK-In1178 D

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By: Hongkong ChenDate: September 30, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/815,407 Confirmation No. 7982

Applicant : Jürgen Holz

Filed : April 1, 2004

TC/A.U. : 2822

Examiner : Mark V. Prenty

Title: : Method for Fabricating a Semiconductor Structure Using a Protective Layer, and Semiconductor Structure

Docket No. : PEK-In1178 D

Customer No. : 24131

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office action dated July 28, 2005, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.